

## ABSTRACT

The invention relates to an electrostatic microswitch  
5 which is intended to connect electrically two strip conductors  
which are disposed on an insulating support (21), the two  
strip conductors are connected electrically by conducting  
means (38) which are provided in the central part of  
deformable means (28) which can be deformed in relation to the  
10 support under the effect of an electrostatic force generated  
by control electrodes (25, 48; 26, 58). The control electrodes  
are distributed facing one another on the deformable means and  
the support, such as to form capacitive means around the  
aforementioned conducting means. The control electrodes are  
15 associated with insulating stop elements (35, 36) which are  
provided in order to prevent a short circuit between  
electrodes of the capacitive means during the deformation of  
the deformable means. The distance between the deformable  
means and the ends of the strip conductors is less than or  
20 equal to the distance between the insulating stop elements  
associated with the control electrodes and the  
control electrodes located opposite.